L Number	Hits	Search Text		
	287		DB	Time stamp
		conductor same teramic same nitride	EPO; JPO; DERWENT;	2003/02/27 14:10
_	3	/conductor come	IBM_TDB	
	1	( transfer same ceramic same nittide) and	EPO; JPO;	2003/02/25 16:14
		wafer and probe	DERWENT;	
1_	0	2001222240 (100)	IBM TDB	
_	0	TOUR LEGISTON IN THE STATE OF T	USPAT	2003/02/25 16:15
		TOTAL SELECTION OF THE PROPERTY OF THE PROPERT	USPAT	2003/02/25 16:15
_	0	2001200210.0KIN.	USPAT	2003/02/25 16:15
_	1	2001148405.URPN.	USPAT	2003/02/25 16:15
	-	2002-208782.NRAN.	DERWENT	2003/02/25 16:15
	1	2002-271649.NRAN.	DERWENT	2003/02/25 16:15
	0	2001223249.URPN.	USPAT	2003/02/25 16:16
_	17	conductor same ceramic same nitride and	EPO; JPO;	2003/02/25 16:54
		wafer	DERWENT;	
		0000 00101	IBM TDB	
	1	2002-321836.NRAN.	DERWENT	2003/02/25 16:35
	0	2001206772.URPN.	USPAT	2003/02/25 16:51
_	0	2001206772.URPN.	USPAT	2003/02/25 16:51
	1	2002-283782.NRAN.	DERWENT	2003/02/25 16:51
_	1	("6475606").PN.	USPAT;	2003/02/25 16:54
			US-PGPUB	2003/02/23 10.54
-	4	peltier same wafer same prob\$	USPAT;	2003/02/27 12:00
			US-PGPUB	2003/02/27 12.00
-	199	peltier same wafer	USPAT;	2003/02/27 12:01
			US-PGPUB	2003/02/27 12.01
-	35	peltier near device same wafer	USPAT;	2003/02/27 12:01
			US-PGPUB	2003/02/2/ 12.01
-	7	("3067310"   "4034207"   "4443691"	USPAT	2003/02/27 12:32
Ì		"5068517"   "5072236"   "6080970"		2003/02/2/ 12.32
		"6133557").PN.		
- !	1	("6475606").PN.	USPAT;	2003/02/27 13:44
			US-PGPUB	2003/02/2/ 13:44
-	1	("6215545").PN.	USPAT;	2003/02/27 14:11
	.		US-PGPUB	2003/02/2/ 14:11
-	1	("5231291").PN.	USPAT;	2003/02/27 14:11
İ	ĺ		US-PGPUB	2003/02/2/ 14:11
-	1	("5220171").PN.	USPAT;	2003/02/27 14:12
			US-PGPUB	2003/02/2/ 14:12
-	1	("4385434").PN.	USPAT;	2002/02/27 14 17
			US-PGPUB	2003/02/27 14:17
-	233	peltier adj device	EPO; JPO;	2002/02/27 14 10
				2003/02/27 14:18
1	ļ		DERWENT;	
-	3	peltier adj device and wafer	IBM_TDB	2222/22/27
1		I may be to a did water	EPO; JPO;	2003/02/27 14:18
			DERWENT;	
- 1	26	peltier adj device	IBM_TDB	0000/00/05
-		peltier adj device and (wafer	USOCR	2003/02/27 14:21
		semiconductor)	USOCR	2003/02/27 14:22
-		peltier adj device and wafer	HCOCD	2002/00/0=
		T wall govice and water	USOCR	2003/02/27 14:22